

Electronic Acknowledgement Receipt

EFS ID:	1267352
Application Number:	10697676
International Application Number:	
Confirmation Number:	8382
Title of Invention:	CHEMICAL MECHANICAL POLISHING METHOD AND APPARATUS
First Named Inventor/Applicant Name:	Joe G. Tran
Customer Number:	23494
Filer:	Yingsheng Tung/Jackie McBride
Filer Authorized By:	Yingsheng Tung
Attorney Docket Number:	TI-37297
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Application Type:	Utility

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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Drawings	TI-37297_DRAWINGS.pdf	331380	no	2

Warnings:

Information:**Total Files Size (in bytes):**

331380

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.